

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of Applicants: Date: December 16, 2009  
Haight et al. Group Art Unit: 3742  
Serial No.: 09/933,461 Examiner: Geoffrey S. Evans  
Filed: August 20, 2001 Docket No.: YOR919980510US2  
For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## **AMENDMENT**

Amendments to the Specification begin on 2 page of this paper.

Remarks begin on 3 page of this paper.